

INFORMATION DISCLOSURE CITATION

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Applicant	Hiroshi TOYODA, et al.		
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U.S. PATENT DOCUMENTS						
Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
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	5,578,523	11/1996	Fiordalice et al.			
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	11-102911	04/1999	Japan			No
	6-275612	09/1994	Japan			Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)	
	Wolf, "Silicon Processing for the VLSI Era, Vol. 2 - Process Integration," 1990, Lattice Press, Vol. 2, p. 193

Examiner:	Date Considered: 1/5/04
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